



Our Ref. No.: 003531.P011

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of: )  
 )  
Jan-Jaco Marco Wieland et al. )  
 ) Examiner: Fuller, Rodney Evan  
Application No.: 10/692,632 )  
 )  
Filed: October 24, 2003 ) Art Unit: 2819  
 )  
For: **LITHOGRAPHY SYSTEM** )  
\_\_\_\_\_ )

Mail Stop – RCE  
Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT**

Dear Commissioner:

Please amend the above-identified application as follows.

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